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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jan Harries HANSEN et al.  
International Application No.: PCT/DK03/00222  
International Filing Date: 2 April 2003  
Priority Date Claimed: 15 April 2002  
For: METHOD AND APPARATUS FOR MEASURING LIGHT  
REFLECTIONS OF AN OBJECT

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Arlington, VA 22313-1450  
Attn: DO/EO/US

S I R:

Prior to examination of the above captioned  
application, kindly amend the application as follows: